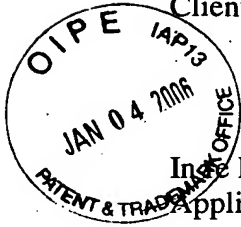


Attorney Docket: 040021-0306769
Client Reference: OPP 031059 US



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: PATENT APPLICATION of: CHOI
Application No.: 10/735,912

Confirmation Number: 3859
Group Art Unit: 1763

Filed: December 16, 2003

Examiner: Jeffrie Lund

Title: CHEMICAL VAPOR DEPOSITION APPARATUS AND METHOD

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the one-month Office Action dated December 5, 2005, Applicant elects Group I, encompassing claims 1-8, drawn to a CVD apparatus, for examination in this application without traverse.

Applicant maintains the right to file a divisional application for non-elected claims in Group II at a later time and respectfully requests an early and favorable examination on the merits of the elected claims.

Respectfully submitted,
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